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_	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/695,189	KIM, JOO W.
	Examiner	Art Unit
	David P. Stitzel, Esq.	1616

	SEARCHED		
Class	Subclass	Date	Examiner
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
PALM (updated inventor name search)	11/20/2006	DP\$
EAST (see attached search notes)	11/20/2006	DPS